



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Lucius M. Sherwin

Atty Docket: TI-30661

Serial No: 09/921,364

Art Unit: 2877

Filed: 08/02/2001

Examiner: Brown, K.

Conf. No. 6223

Not. of Allow.: 03/29/2004

For: A PARTICLE DETECTION AND REMOVAL APPARATUS FOR USE ON
WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED DEFECTS FROM
PARTICLE CONTAMINATION

LETTER OF TRANSMITTAL

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is being
deposited with the U.S. Postal Service as First Class Mail
in an envelope addressed to: Commissioner of Patents,
P.O. Box 1450, Alexandria, VA 22313-1450.

Date

6-4-04

Marianna Smith
Marianna Smith

Enclosed please find the signed Supplemental Declaration in the above-identified application.

Please charge any necessary fee to Deposit Account No. 20-0668.

Respectfully submitted,

Jacqueline J. Garner
Jacqueline J. Garner
Attorney for Applicant
Reg. No. 36,144

Texas Instruments Incorporated
P.O. Box 655474, MS 3999
Dallas, TX 75265
(214)532-9348 or (972)917-5643
Fax: (972)917-4418